



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#16

In Reply Patent Application : **Group Art Unit: 1754**
Garnier, et al. :
Serial Number: 09/582,049 : **Examiner: Nguyen, Ngoc Yen M.**
:
Filed: September 1, 2000 : **Attn. Docket No.: Garnier-1**
:
Title: Silicon Refining Method and : **Date: May 20, 2005**
Installation :
:

Commissioner for Patents
Washington, D.C. 20231

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OFFICE OF PETITIONS

REPLY TO FINAL OFFICE ACTION

Sir:

This paper is responsive to the Office Action dated September 10, 2002. A petition for revival of an application abandoned unintentionally is included herewith. Kindly enter the following amendments:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.